EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	177	((workpiece or wafer or substrate or sample or semiconductor or film) same (chamber or vessel or enclosure or container or reactor) same plasma) and ((three or third) adj2 frequenc$3)	US-PGPUB; USPAT; USOCR	OR	ON	2007/02/27 20:47
L2	45	((workpiece or wafer or substrate or sample or semiconductor or film) same (chamber or vessel or enclosure or container or reactor) same plasma) and ((three or third) adj2 frequenc$3) and workpiece	US-PGPUB; USPAT; USOCR	OR	ON	2007/02/27 21:39
L3	36	((workpiece or wafer or substrate or sample or semiconductor or film) same (chamber or vessel or enclosure or container or reactor) same plasma) and (((three or third) adj2 frequenc$3) near5 (source or power or suppl$5)) and workpiece	US-PGPUB; USPAT; USOCR	OR	ON	2007/02/27 22:04
L4	20	3 and (applied near2 materials)	US-PGPUB; USPAT; USOCR	OR	ON	2007/02/27 21:51
L5	179	((workpiece or wafer or substrate or sample or semiconductor or film) same (chamber or vessel or enclosure or container or reactor) same plasma) and ((three or third) adj2 (source or power or suppl$5)) and workpiece	US-PGPUB; USPAT; USOCR	OR	ON	2007/02/27 22:08
L6	59	((workpiece or wafer or substrate or sample or semiconductor or film) same (chamber or vessel or enclosure or container or reactor) same plasma) and ((three or third) adj1 (source or power or suppl$5)) and workpiece	US-PGPUB; USPAT; USOCR	OR	ON	2007/02/27 22:09
L7	59	((workpiece or wafer or substrate or sample or semiconductor or film) same (chamber or vessel or enclosure or container or reactor) same plasma) and ((three or third) adj (source or power or suppl$5)) and workpiece	US-PGPUB; USPAT; USOCR	OR	ON	2007/02/27 22:11
L11	1	("20040000875").PN.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/02/27 22:18

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L13	1	"6309978".pn.	US-PGPUB; USPAT; USOCR	OR	OFF	2007/02/27 22:23
L14	17	(((three third plural multi$3) near frequenc$3) near4 (source power)) and workpi$4 and plasma and @ad <"20030822"	US-PGPUB; USPAT; USOCR	OR	OFF	2007/02/27 22:23
L15	17	(((three third plural multi$3) near frequenc$3) near4 (source power)) and workpi$4 and plasma and @ad <"20030822"	US-PGPUB; USPAT; USOCR	OR	ON	2007/02/27 22:24